

Figure 1a - UV Absorption of Combustion Gases

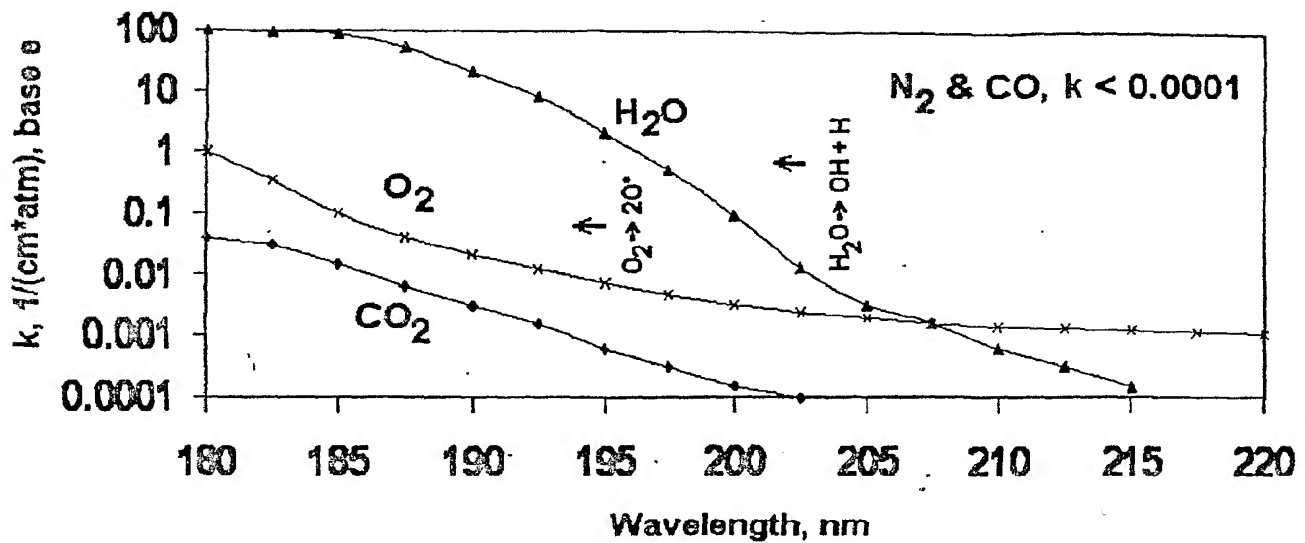
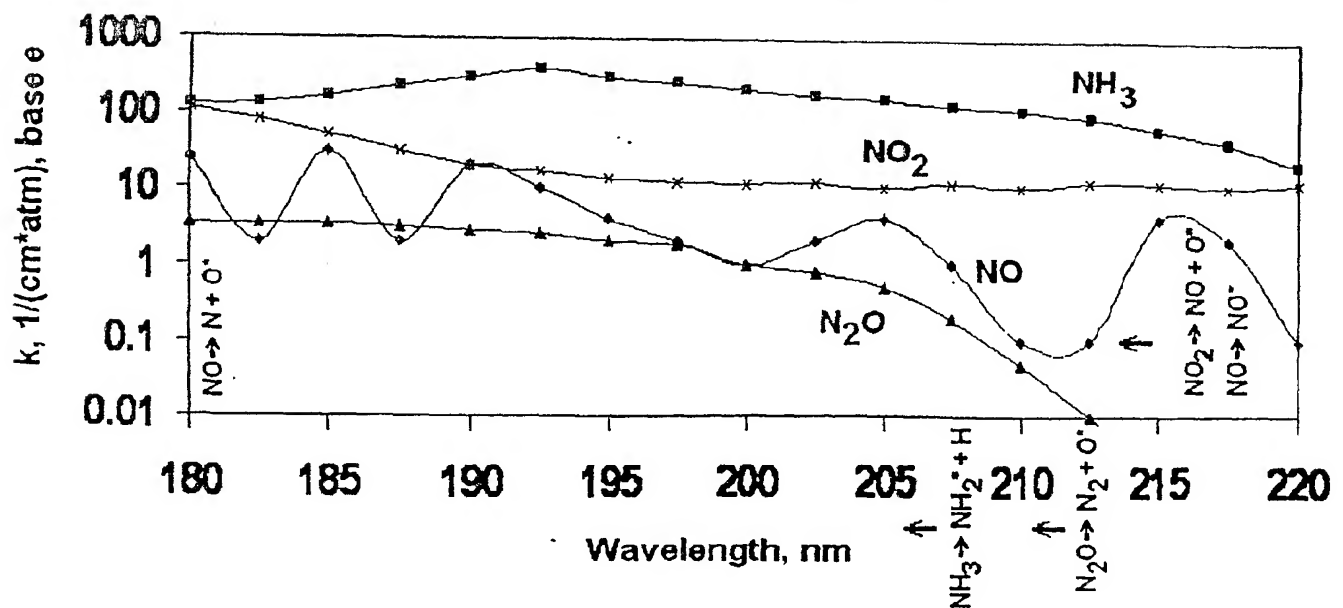
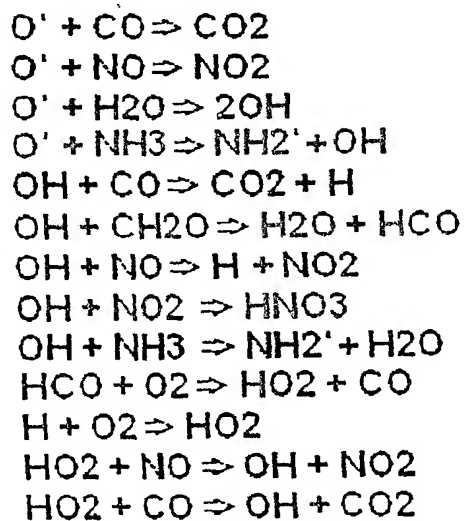


Figure 1b - UV Absorption of Nitrogen Based Gases

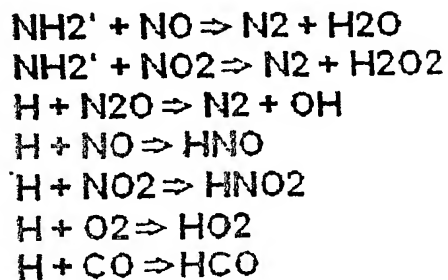


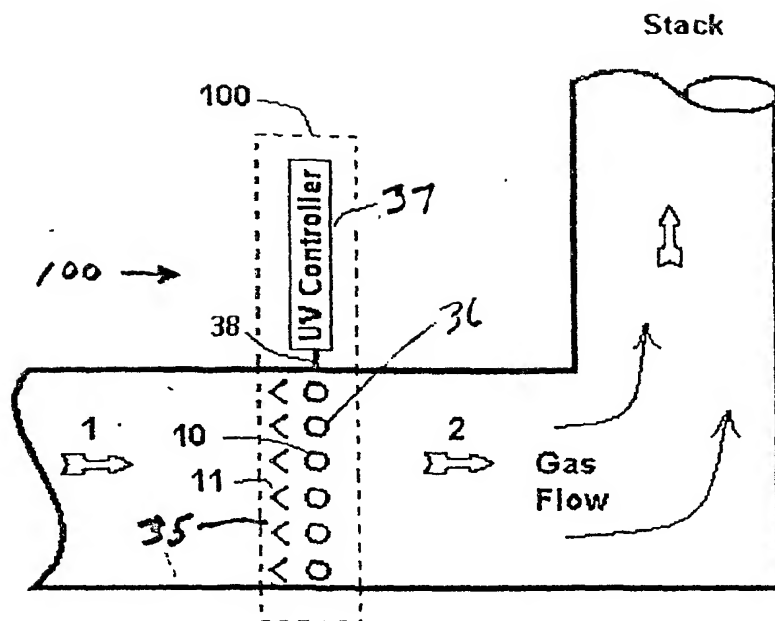
## Figure 1c - Important Secondary Reactions

### Oxidation

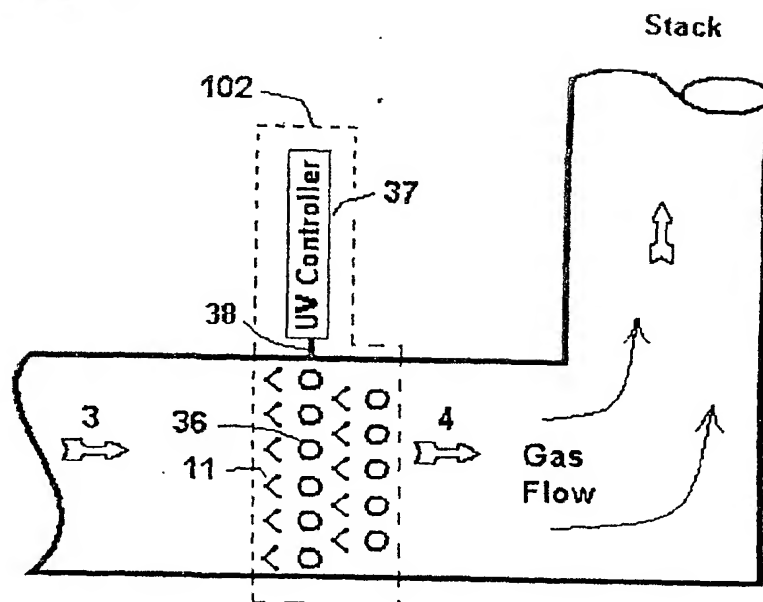


### Reduction





**Figure 2a - Use of SUVR to Destroy Combustion Contaminants and/or VOC's**



**Figure 2b - Use of SUVR to Polish Residual  $\text{NO}_x$  and  $\text{NH}_3$  Gases from an Upstream SNCR, SHR, or SCR Process**

**Figure 3a - SUVR to Control Combustion  
Contaminants and/or VOC's  
plus NO<sub>x</sub> Emissions**

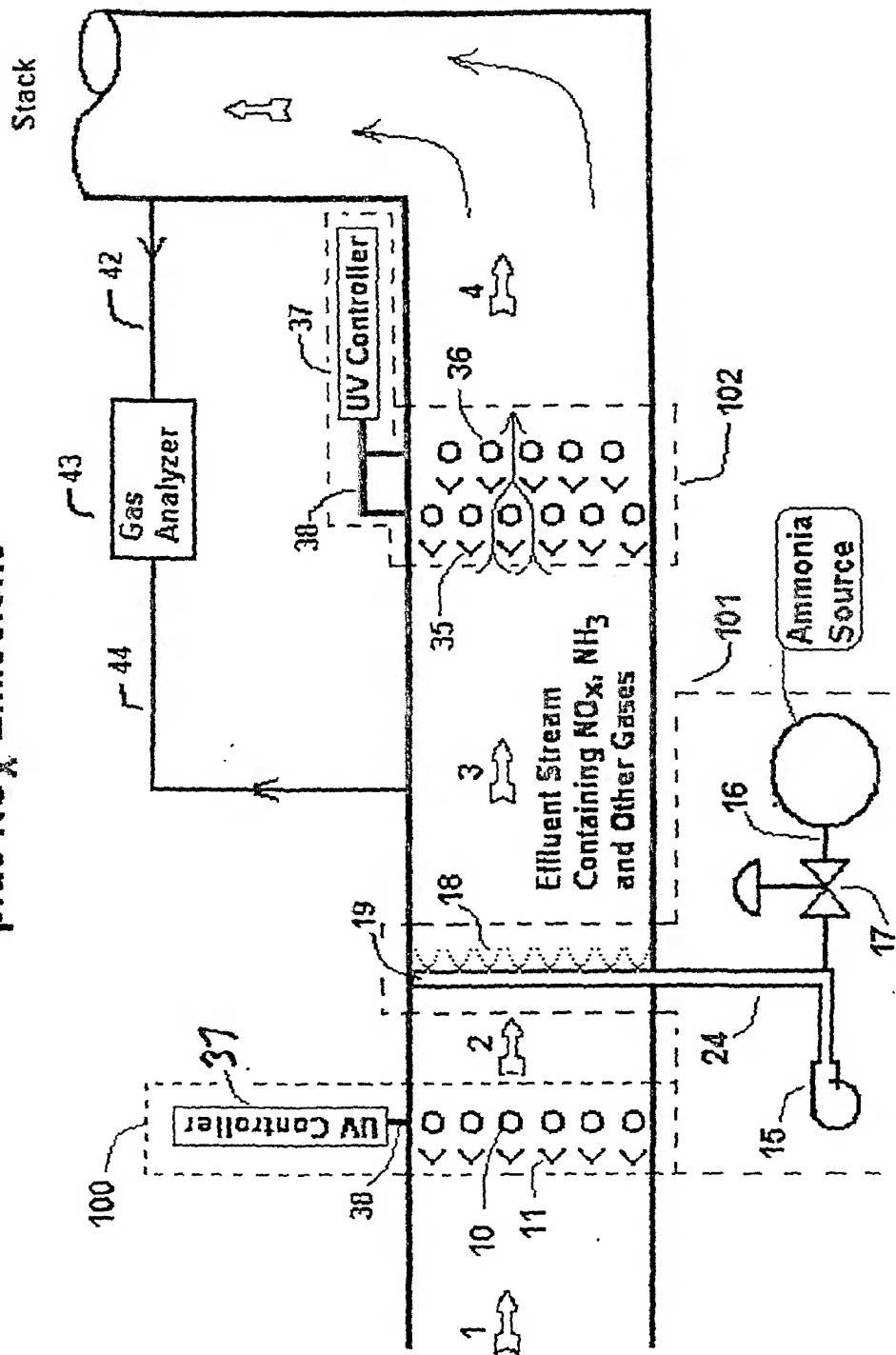
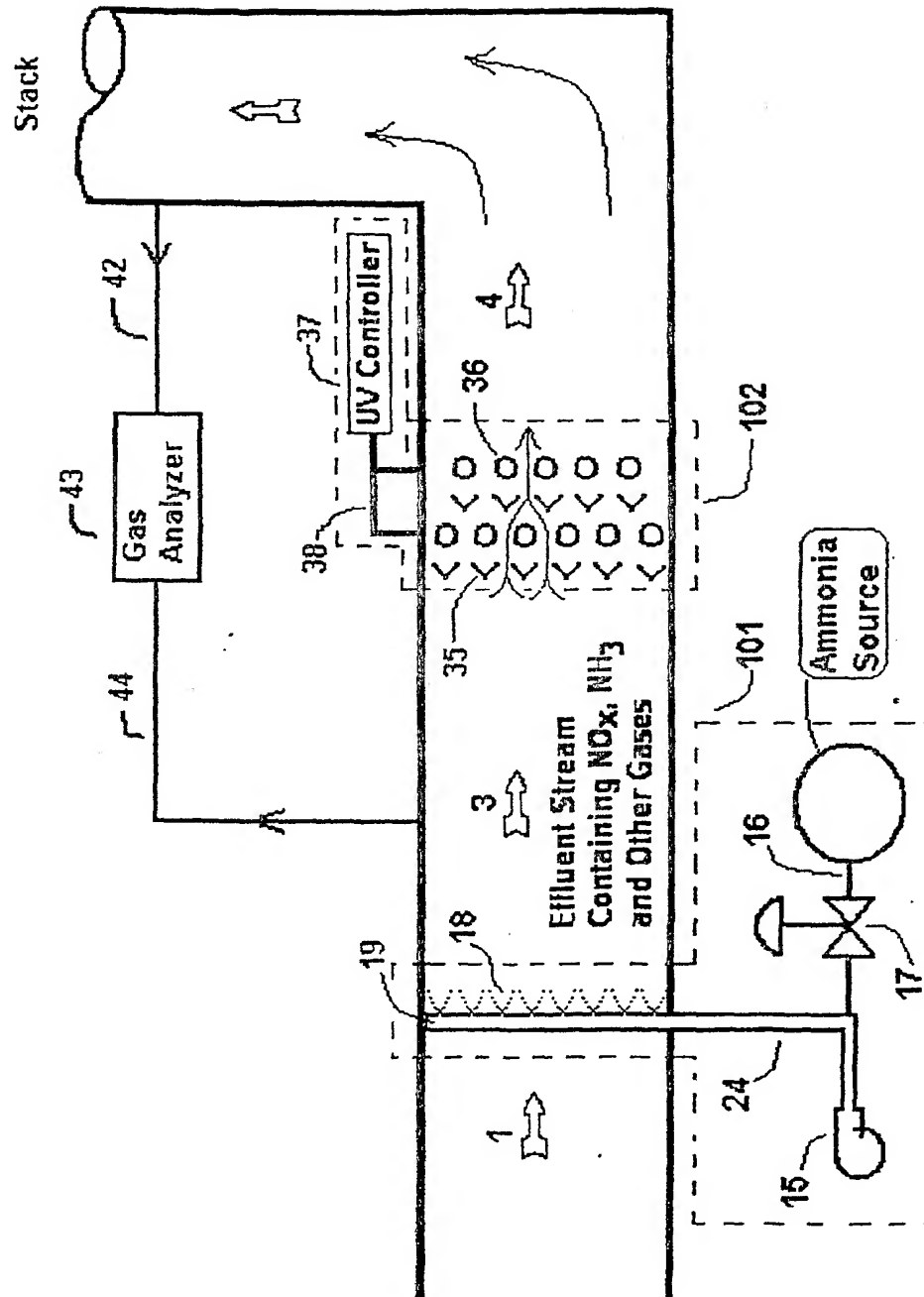
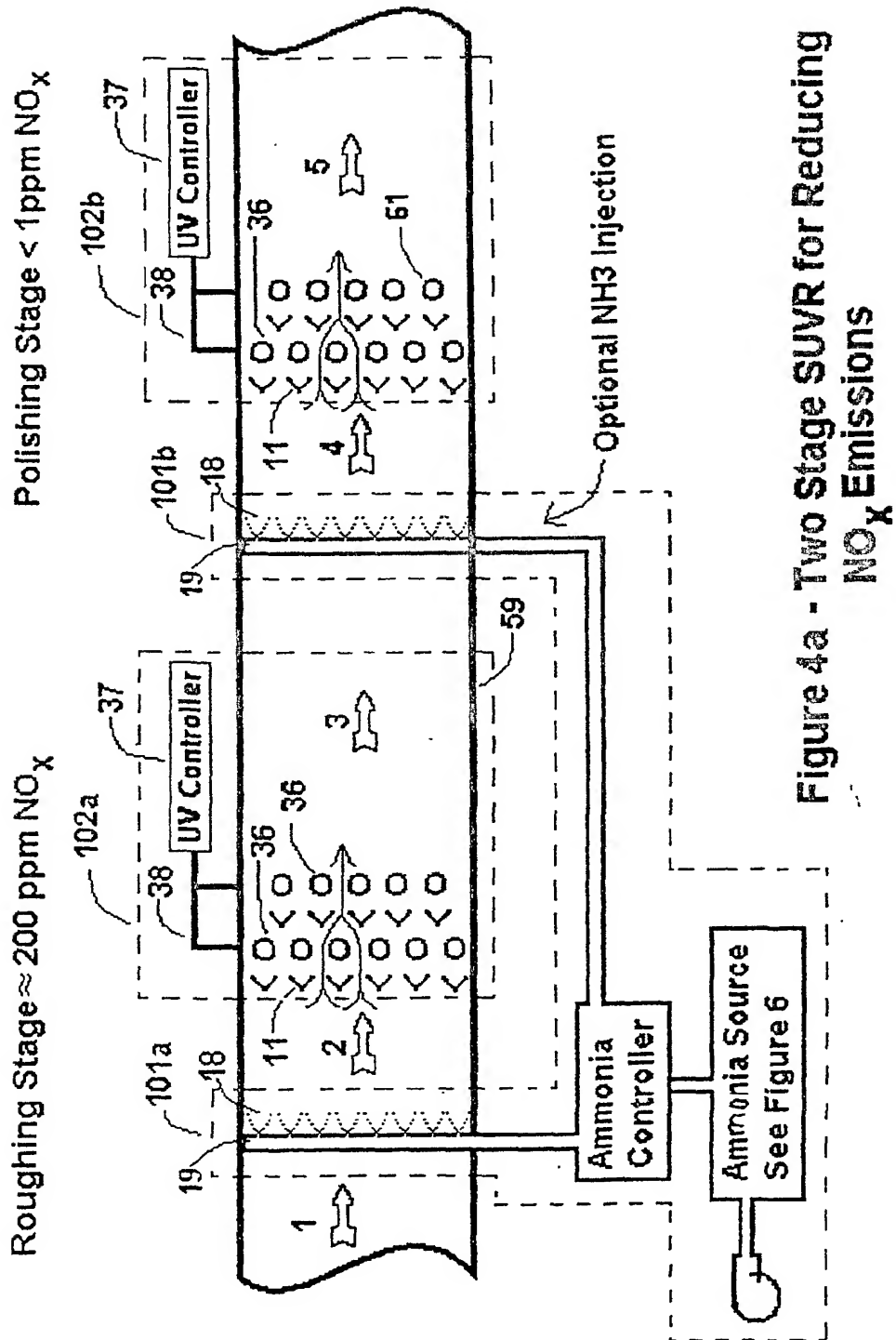


Figure 3b - SUVR to Control NO<sub>x</sub> Emissions



### Figure 4a - Two Stage SUVR for Reducing NO<sub>x</sub> Emissions

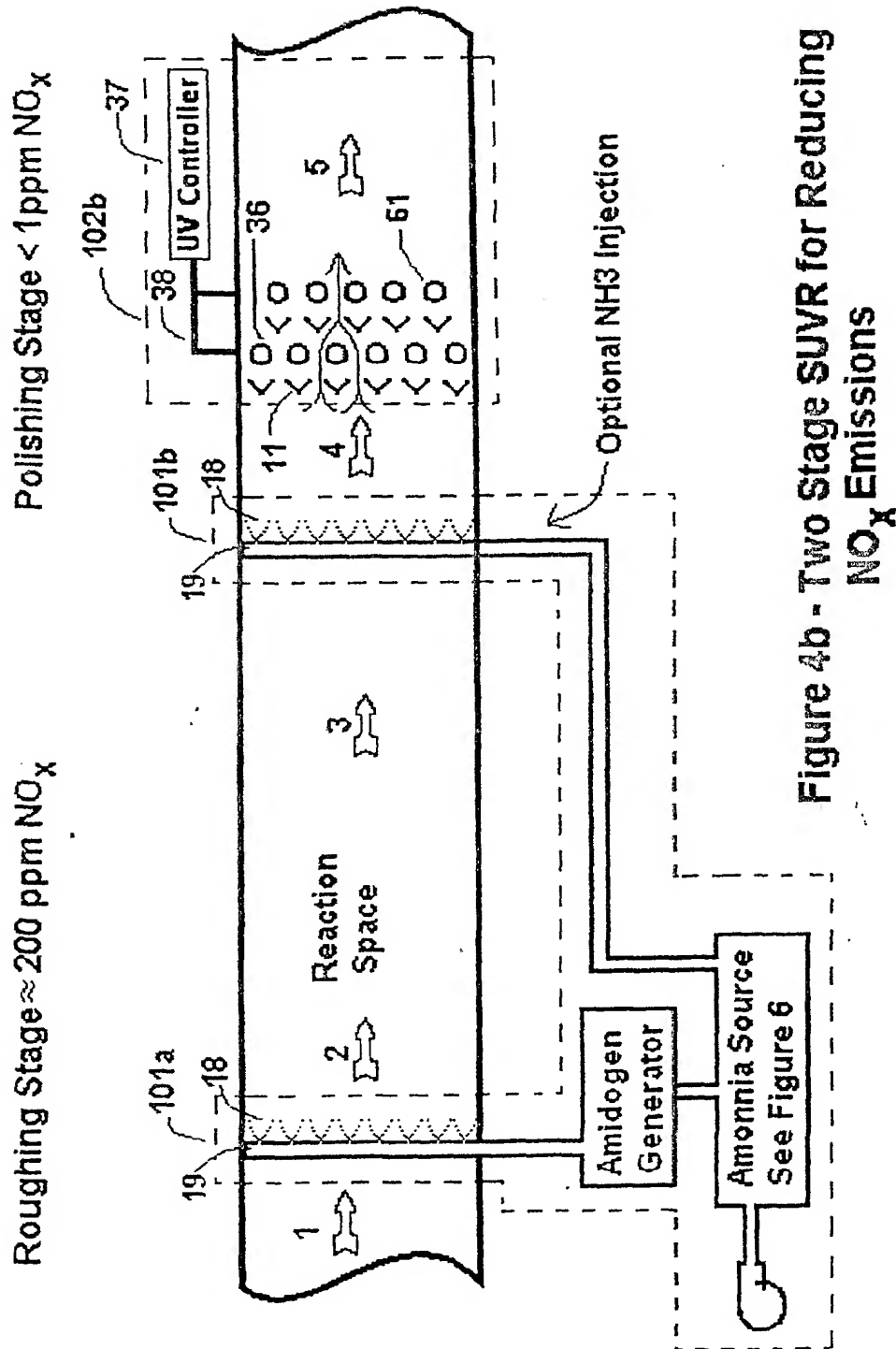
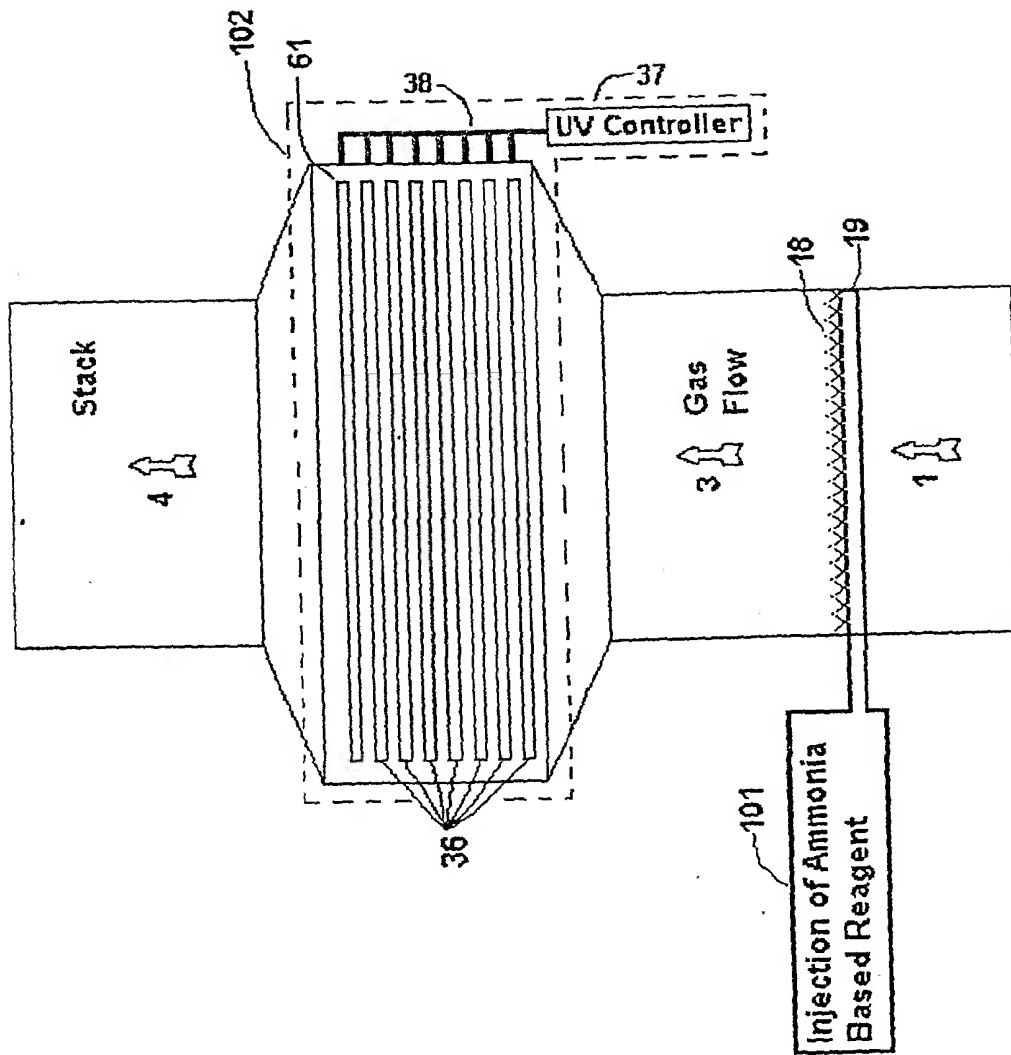


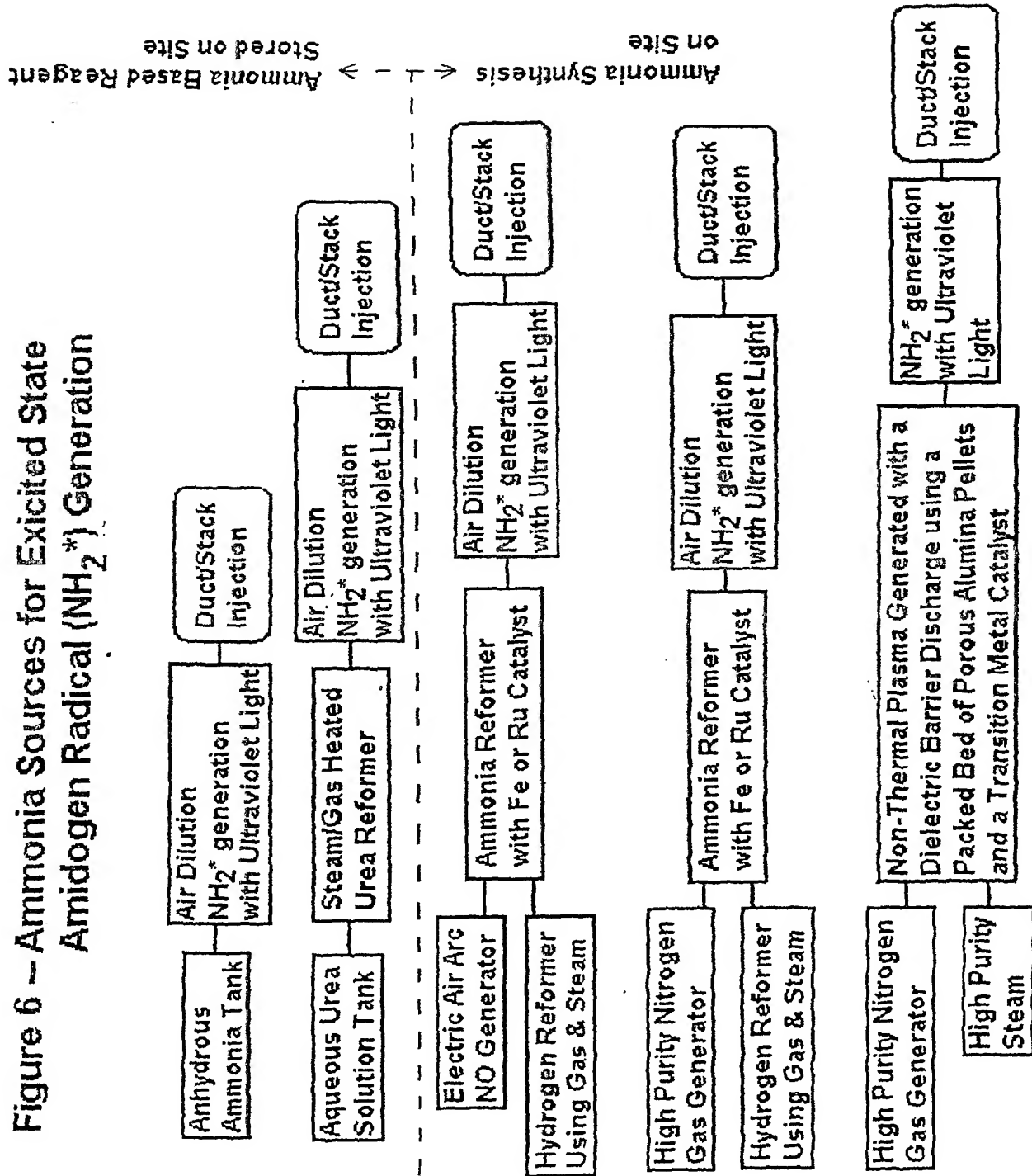
Figure 4b - Two Stage SUVR for Reducing  $\text{NO}_x$  Emissions

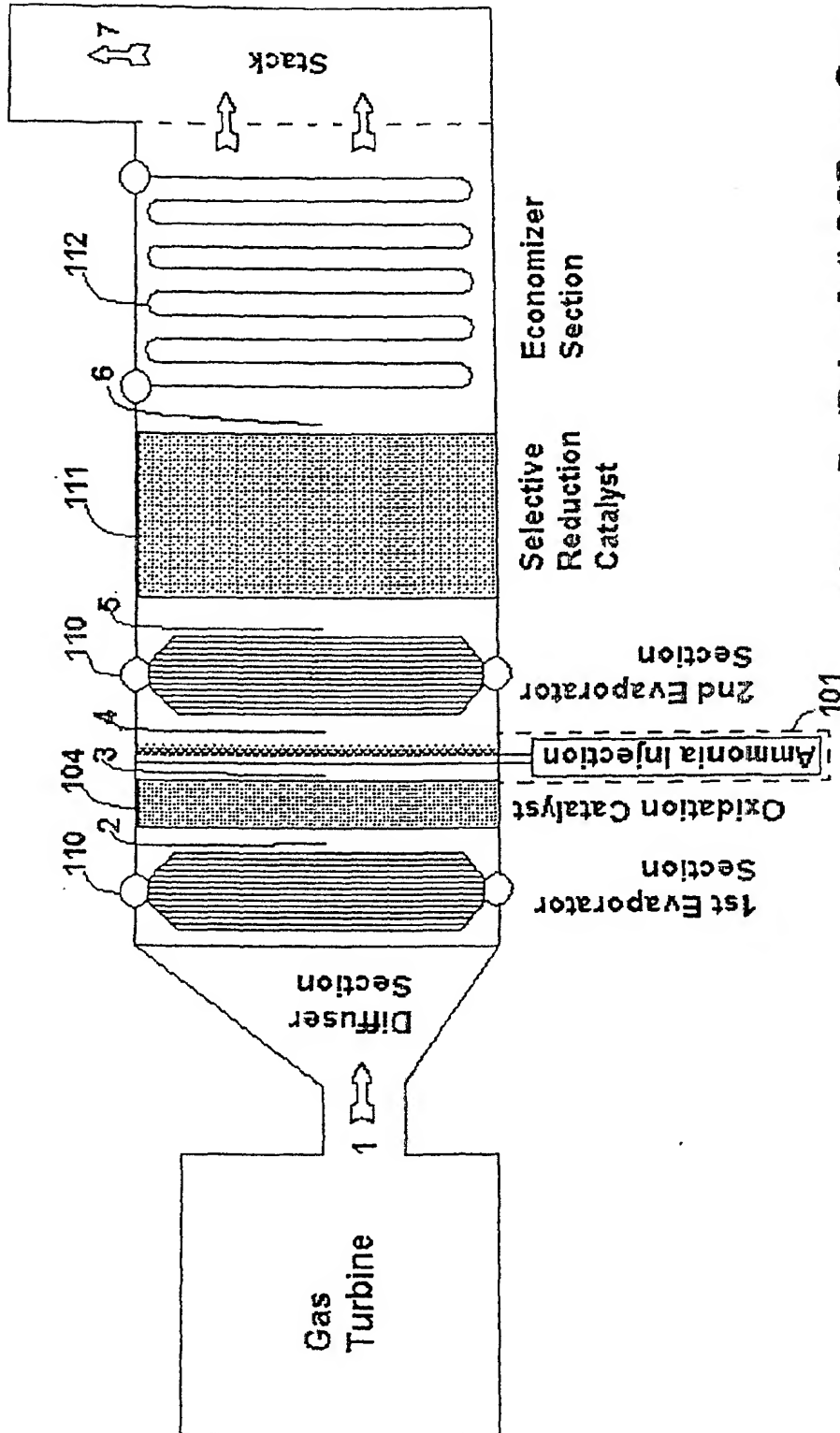


**Figure 5 - Installation of the SUVR process on a Combustion Device to Remove NO<sub>x</sub> and Residual NH<sub>3</sub> Emissions; Replacing the SCR Process**

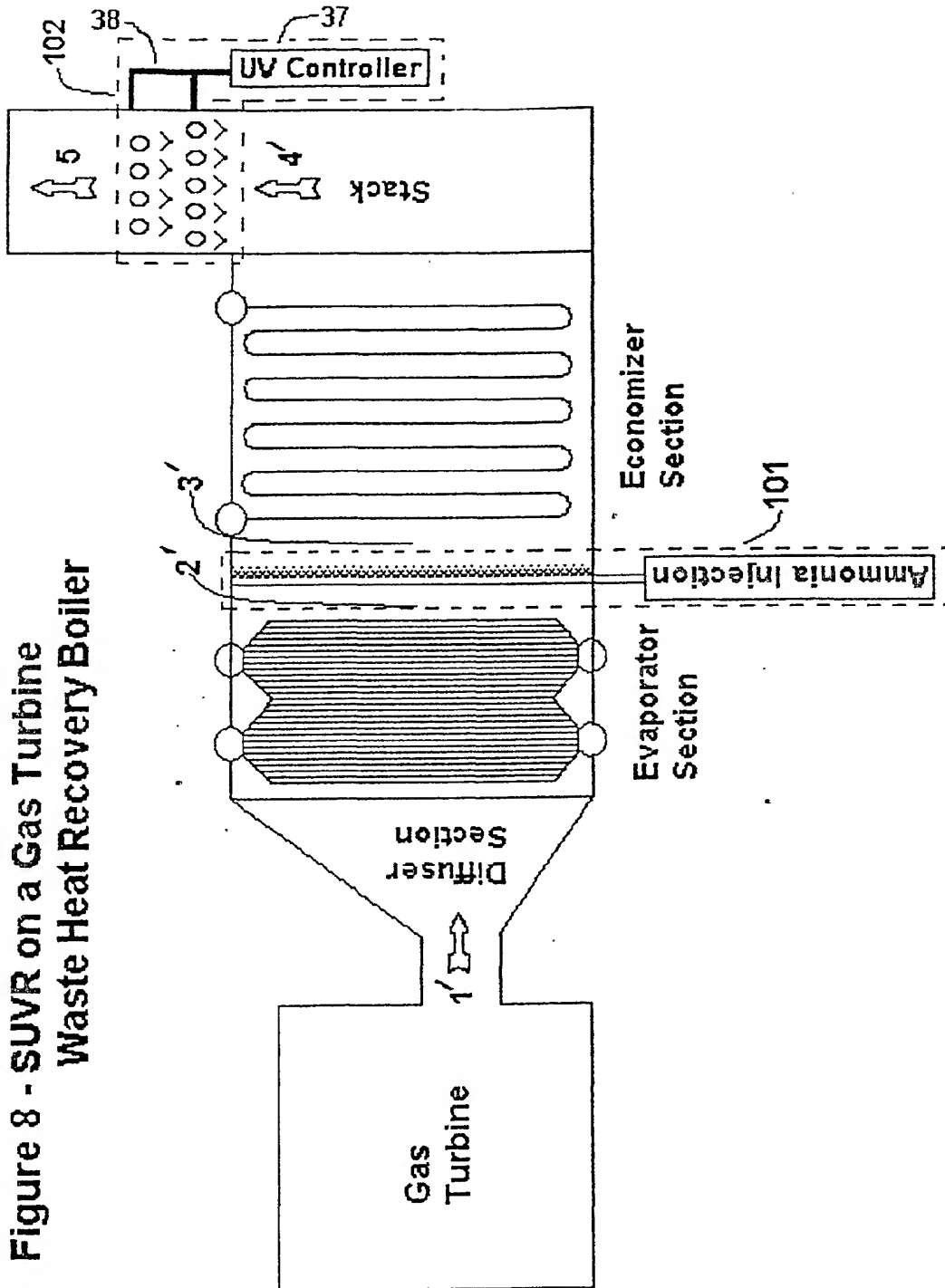


Figure 6 – Ammonia Sources for Excited State Amidogen Radical ( $\text{NH}_2^*$ ) Generation





**Figure 7 - (Prior Art) SCR on Gas Turbine Waste Heat Recovery Boiler**



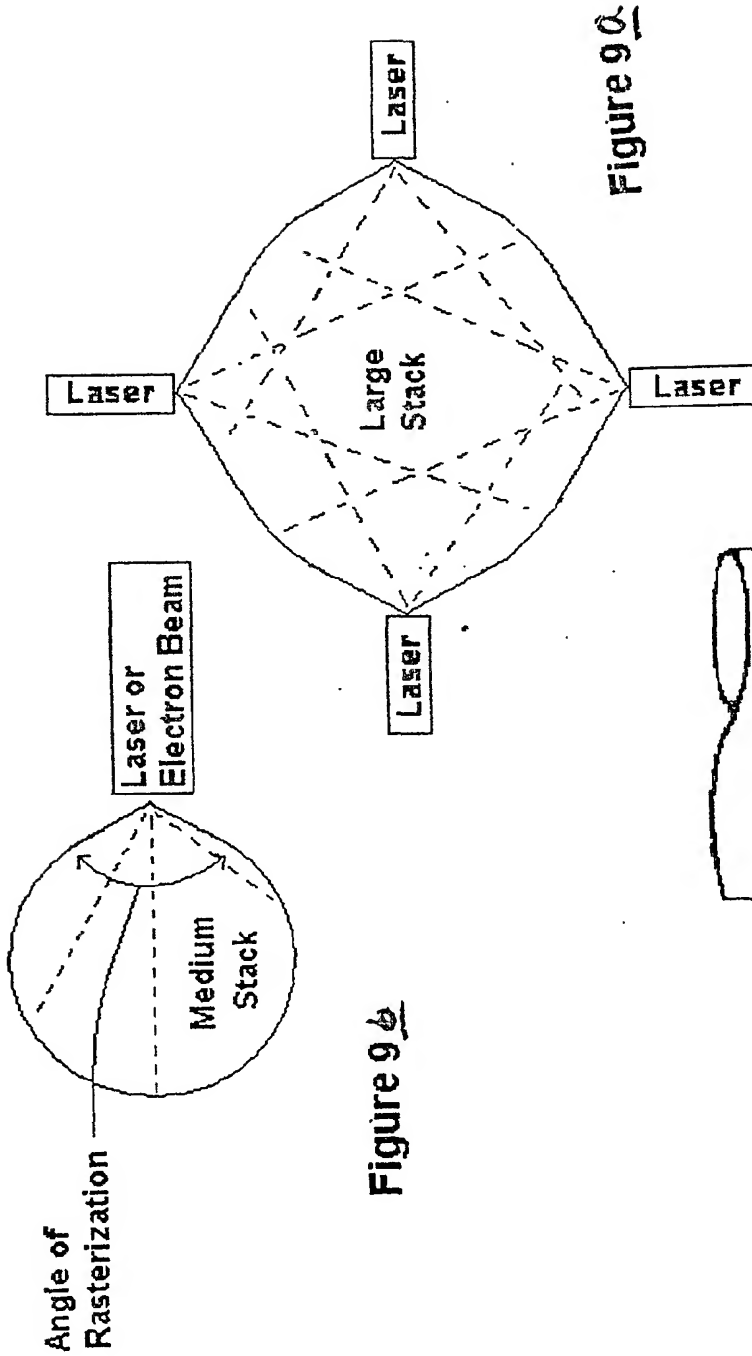


Figure 9a

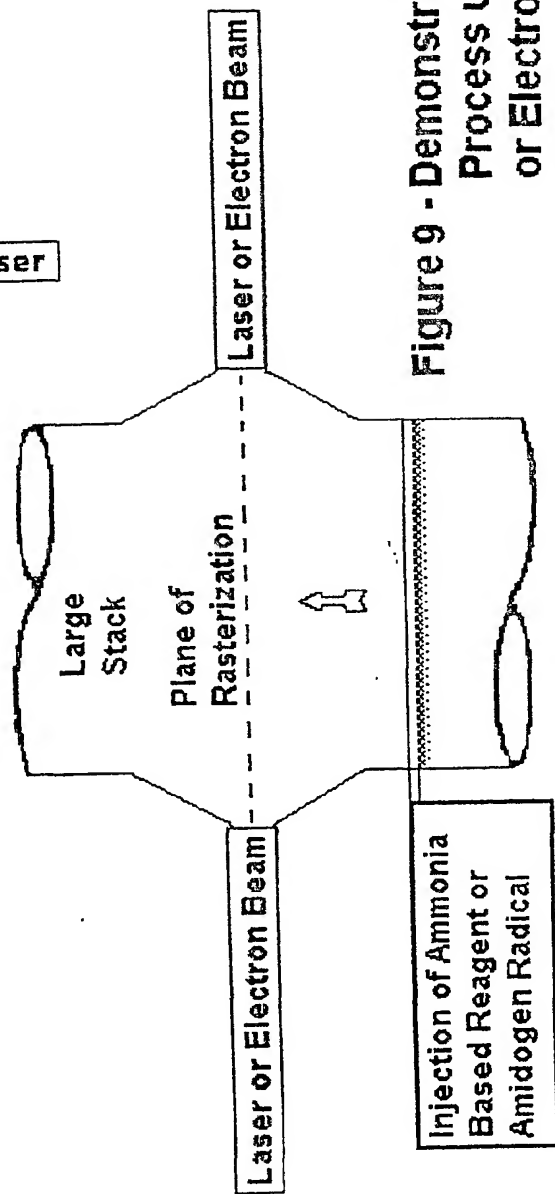
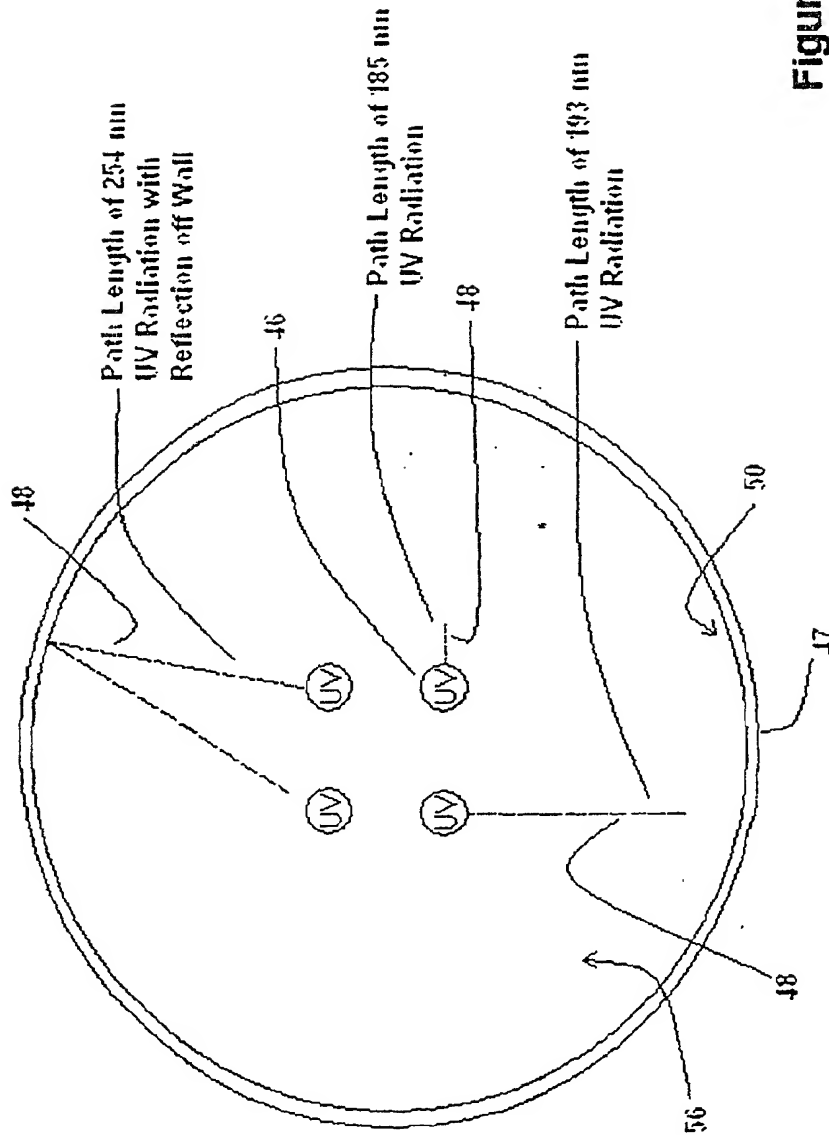
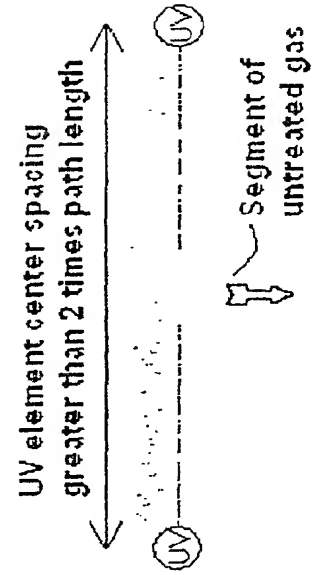


Figure 9 - Demonstration of the SUVR Process using a UV Laser or Electron Beam for Activation

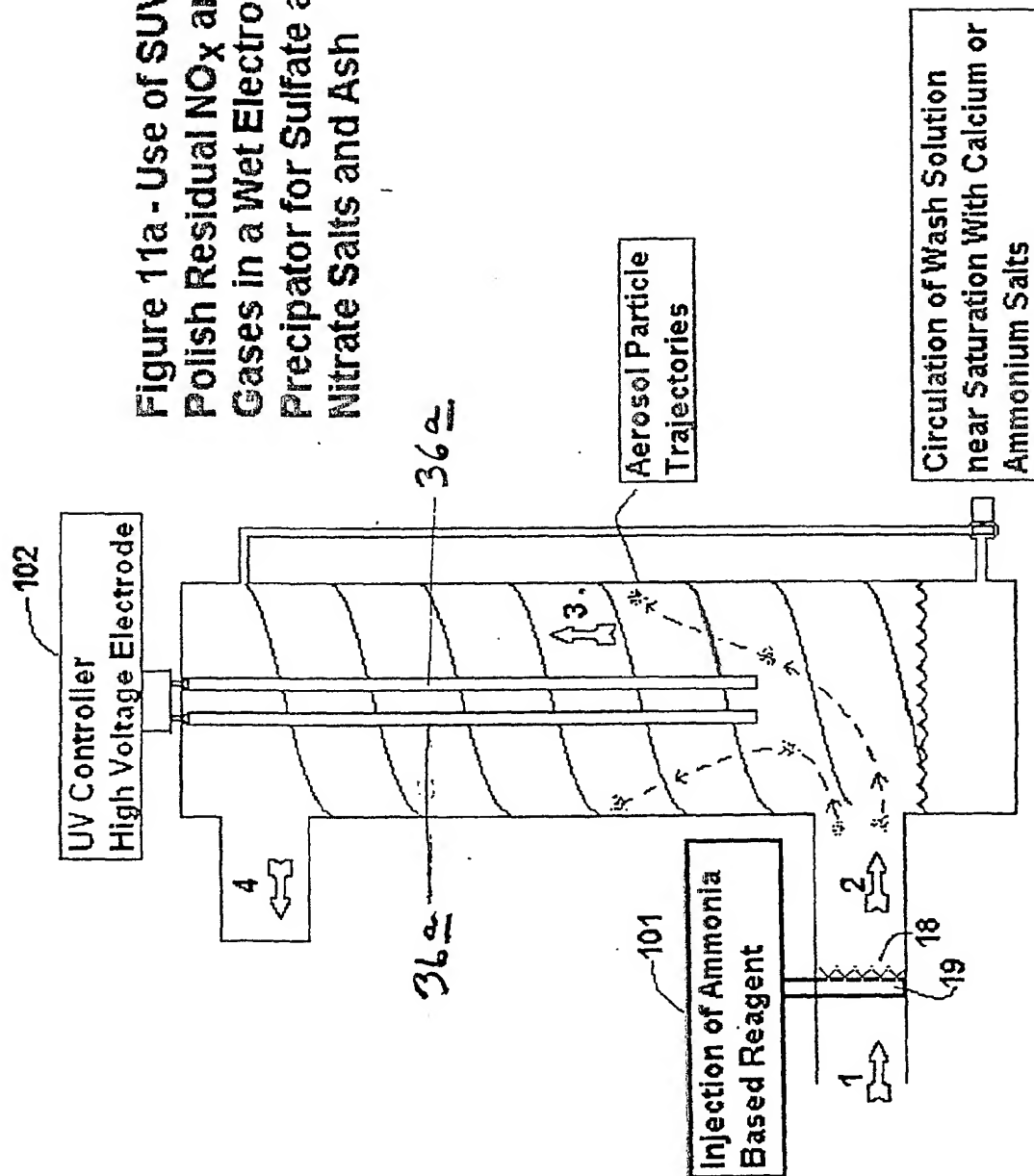


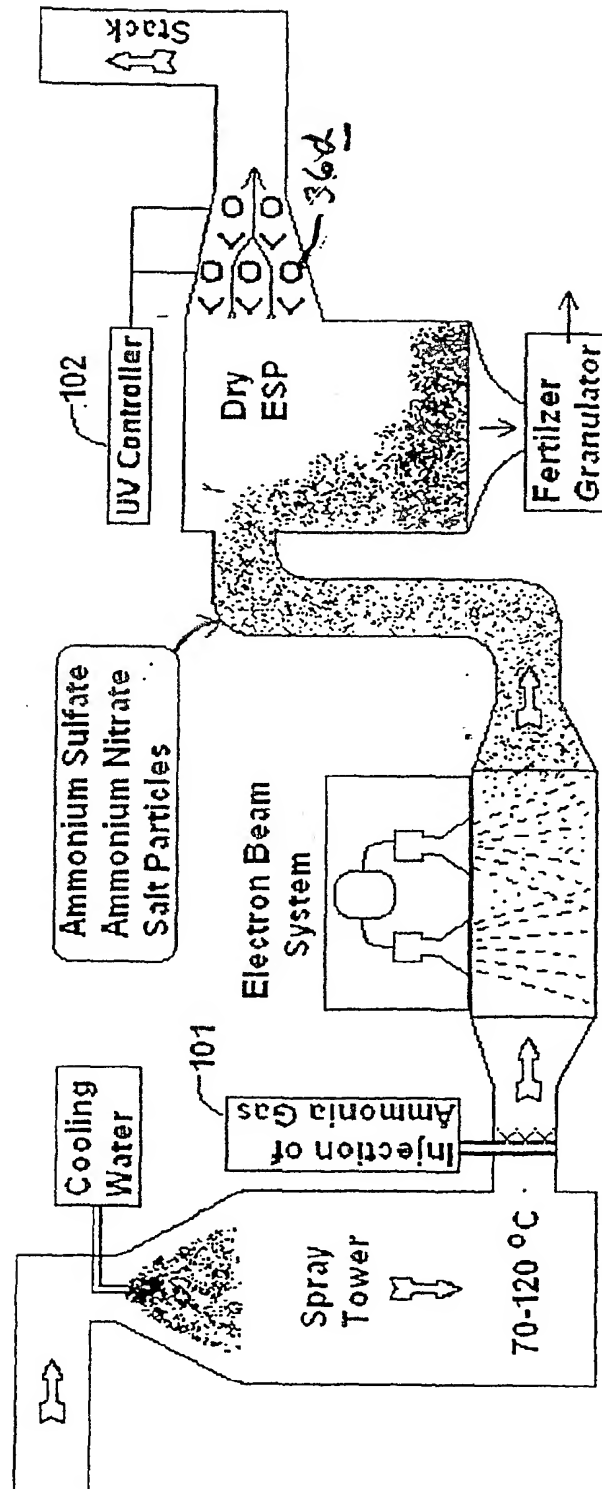
**Figure 10**



**Figure 10 - Relative Transmission Path Lengths of UV lines from a low Pressure Mercury Vapor Lamp**

**Figure 11a - Use of SUVR to Polish Residual NO<sub>x</sub> and NH<sub>3</sub> Gases in a Wet Electrostatic Precipitator for Sulfate and Nitrate Salts and Ash**





**Figure 11b - Use of SUVR to Polish Residual  $\text{SO}_3$ ,  $\text{NO}_x$  and  $\text{NH}_3$  Gases from an Upstream Electron Beam System to Boost Efficiency to over 99%**

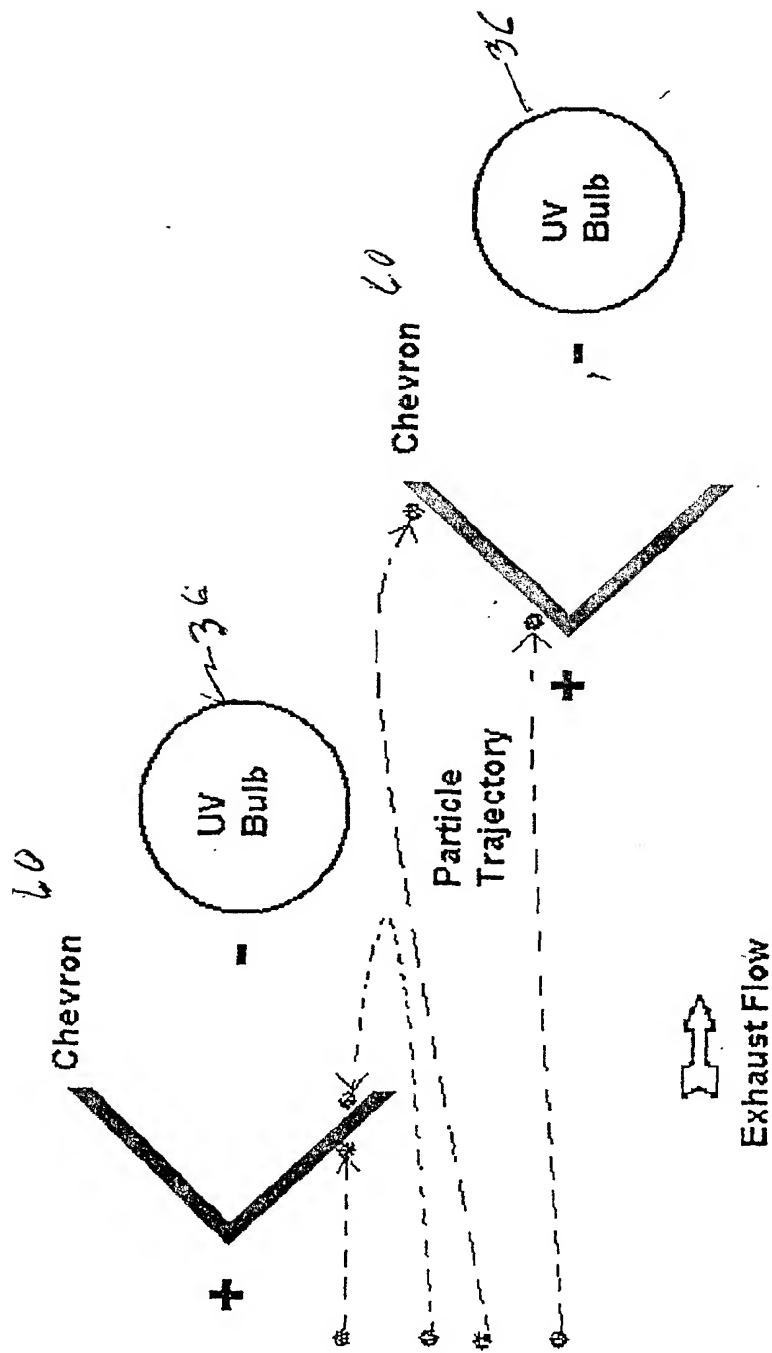
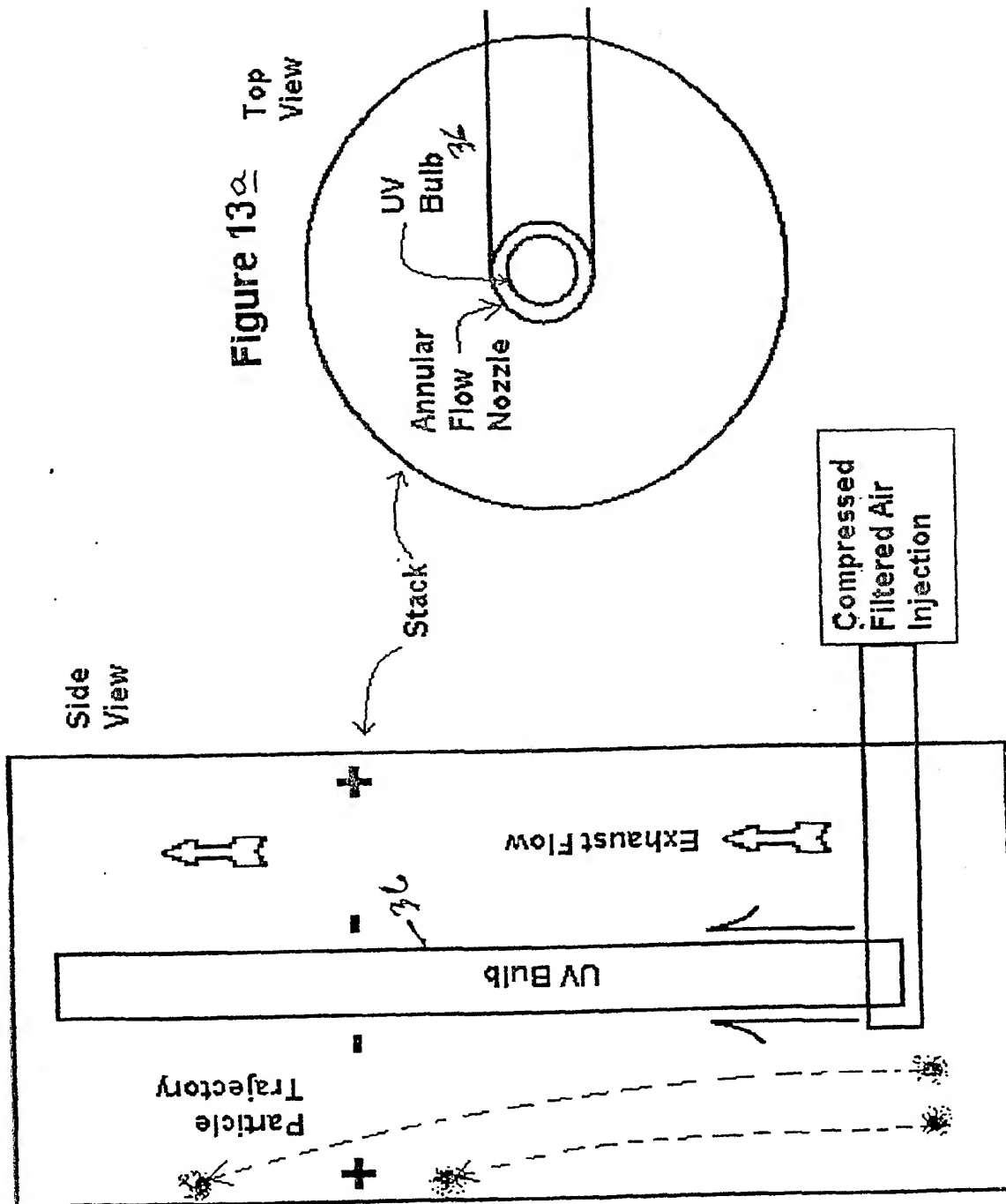


Figure 12 - Electrostatic Field Protection of  
Ultraviolet Bulbs in Dirty Exhaust Gases





**Figure 13 - Electrostatic Field + Boundary Layer of Clean Gas Protection of Ultraviolet Bulb in Very Dirty Exhaust Gases**

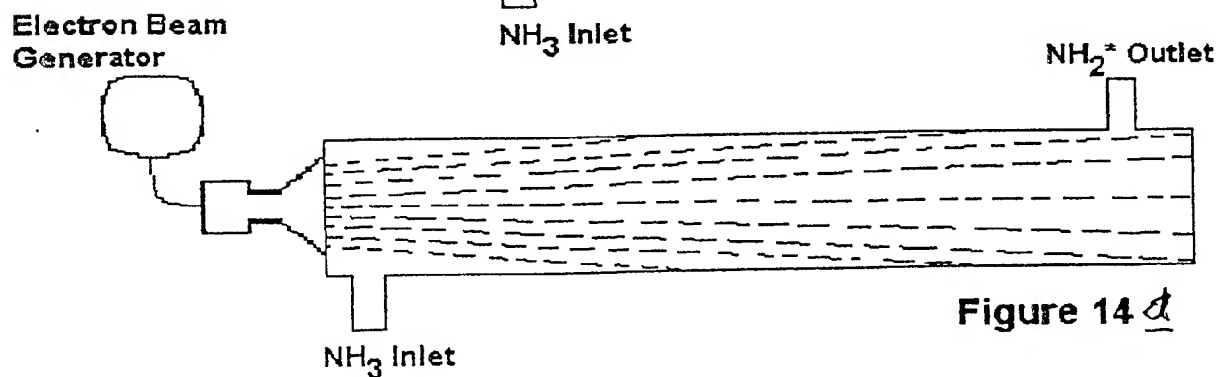
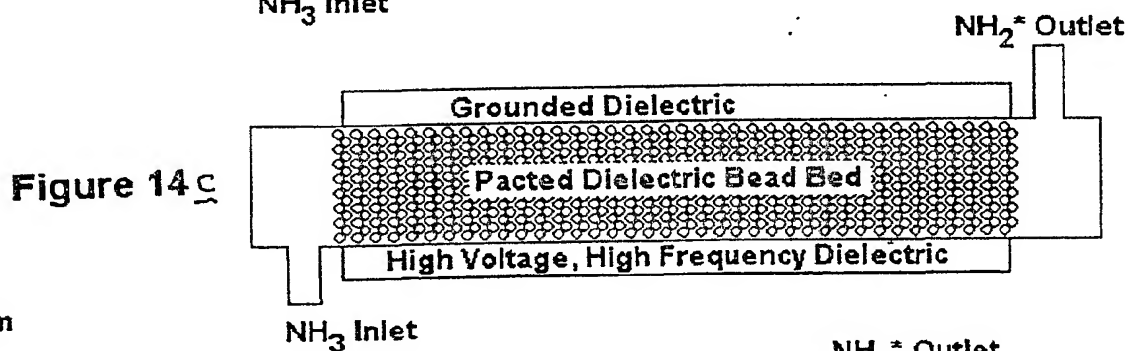
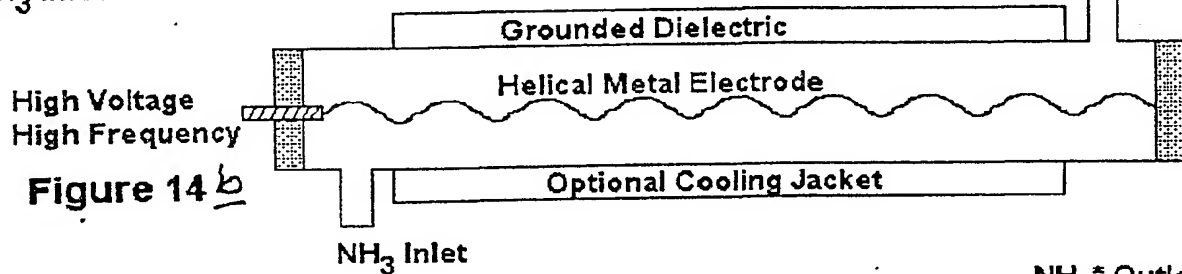
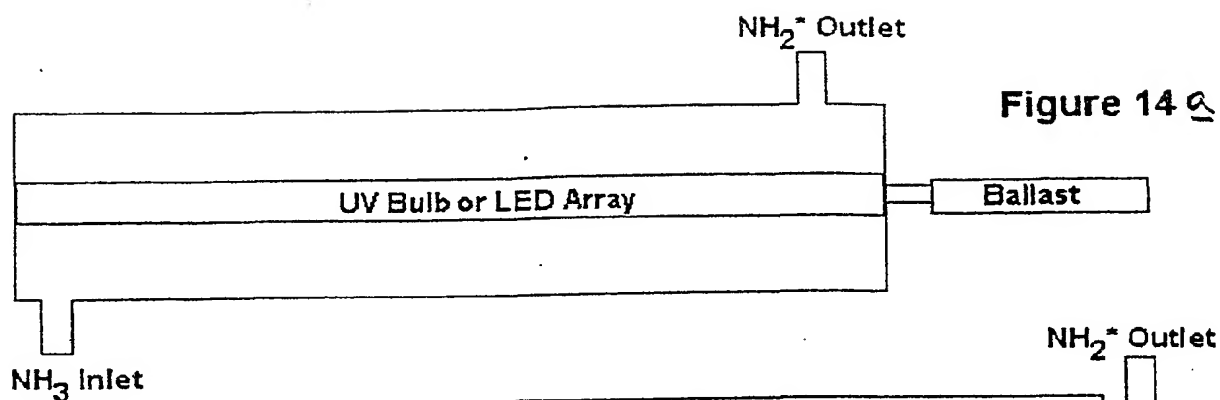


Figure 14 - Amidogen Radical ( $\text{NH}_2^*$ ) Generators

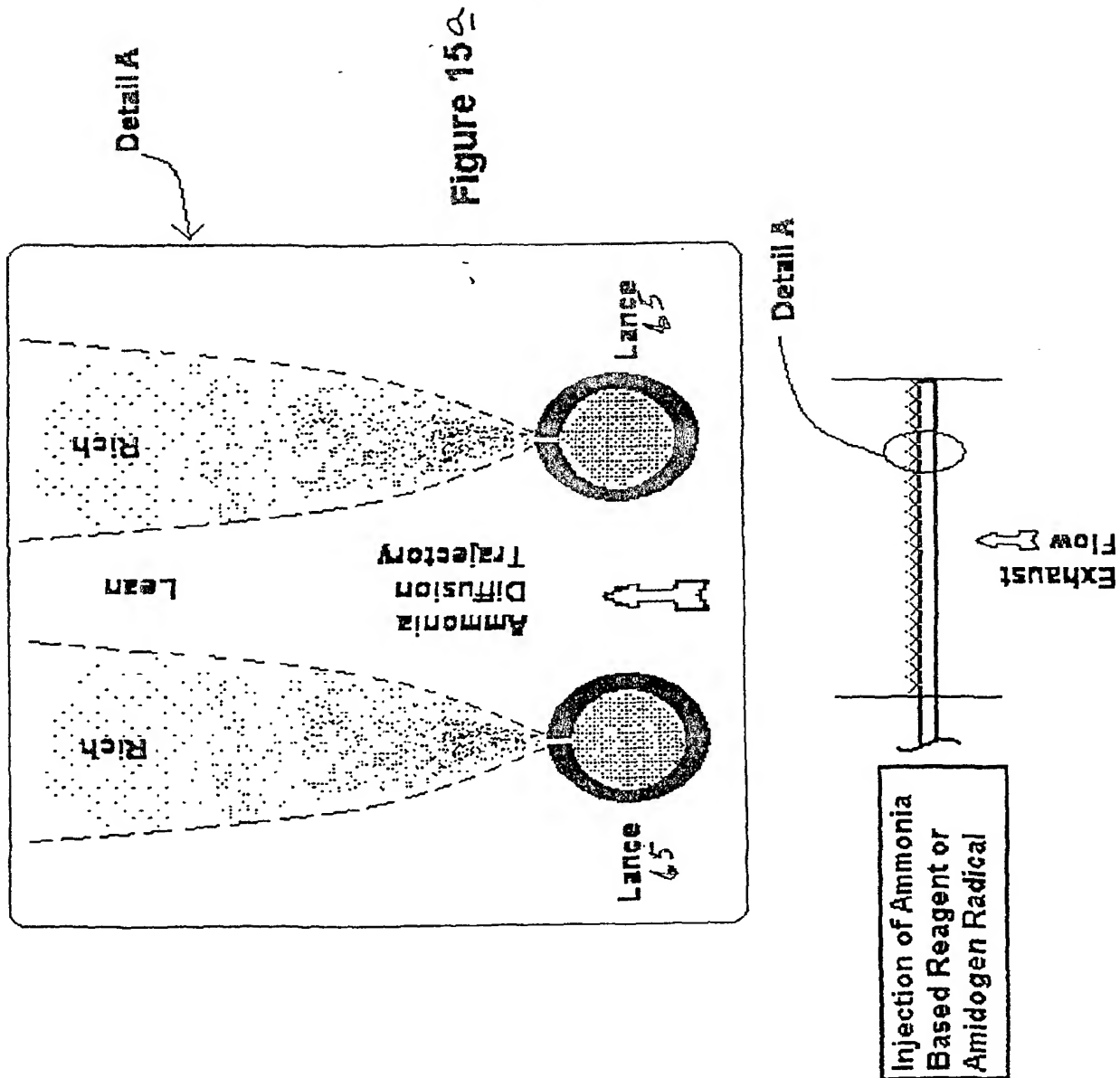
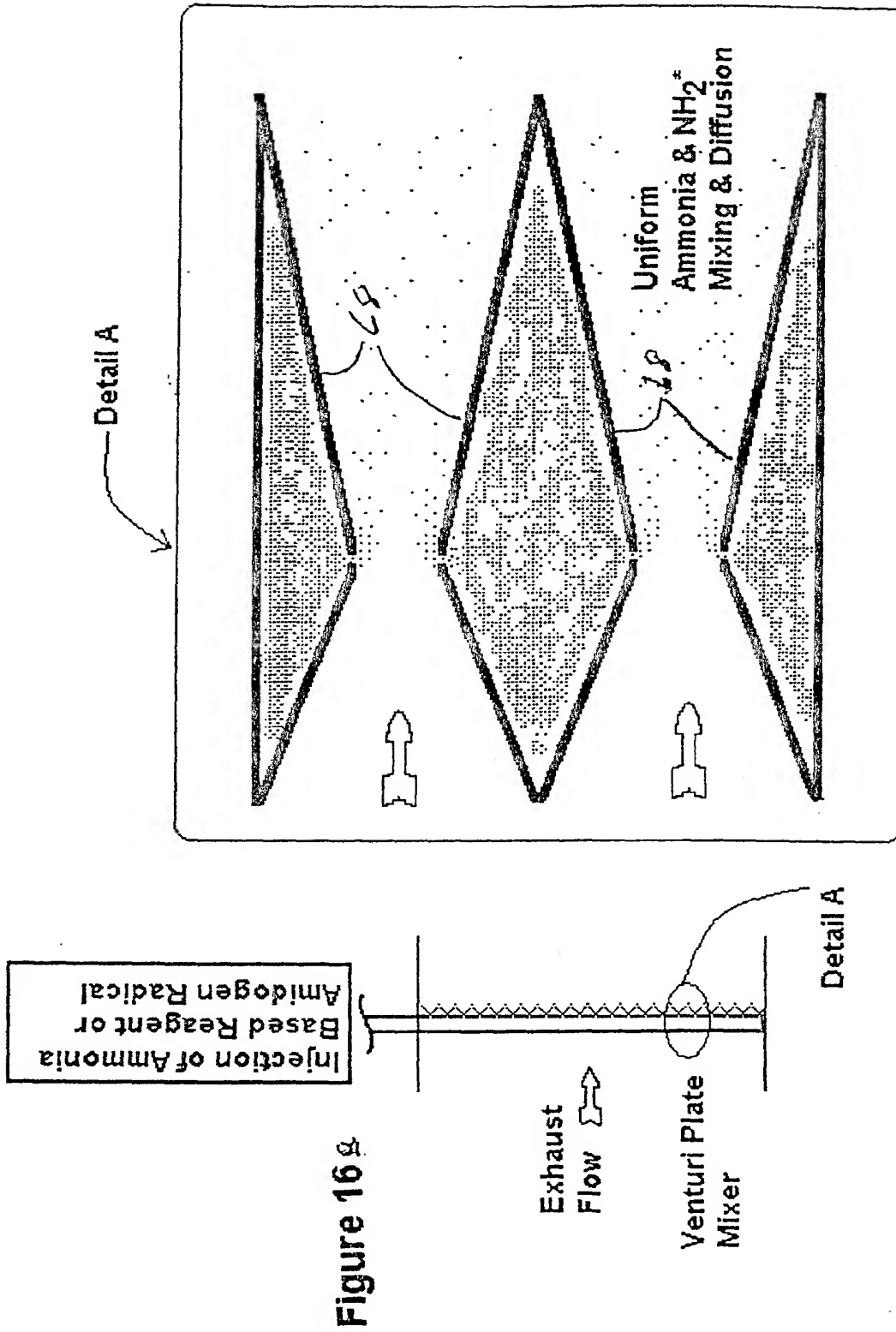
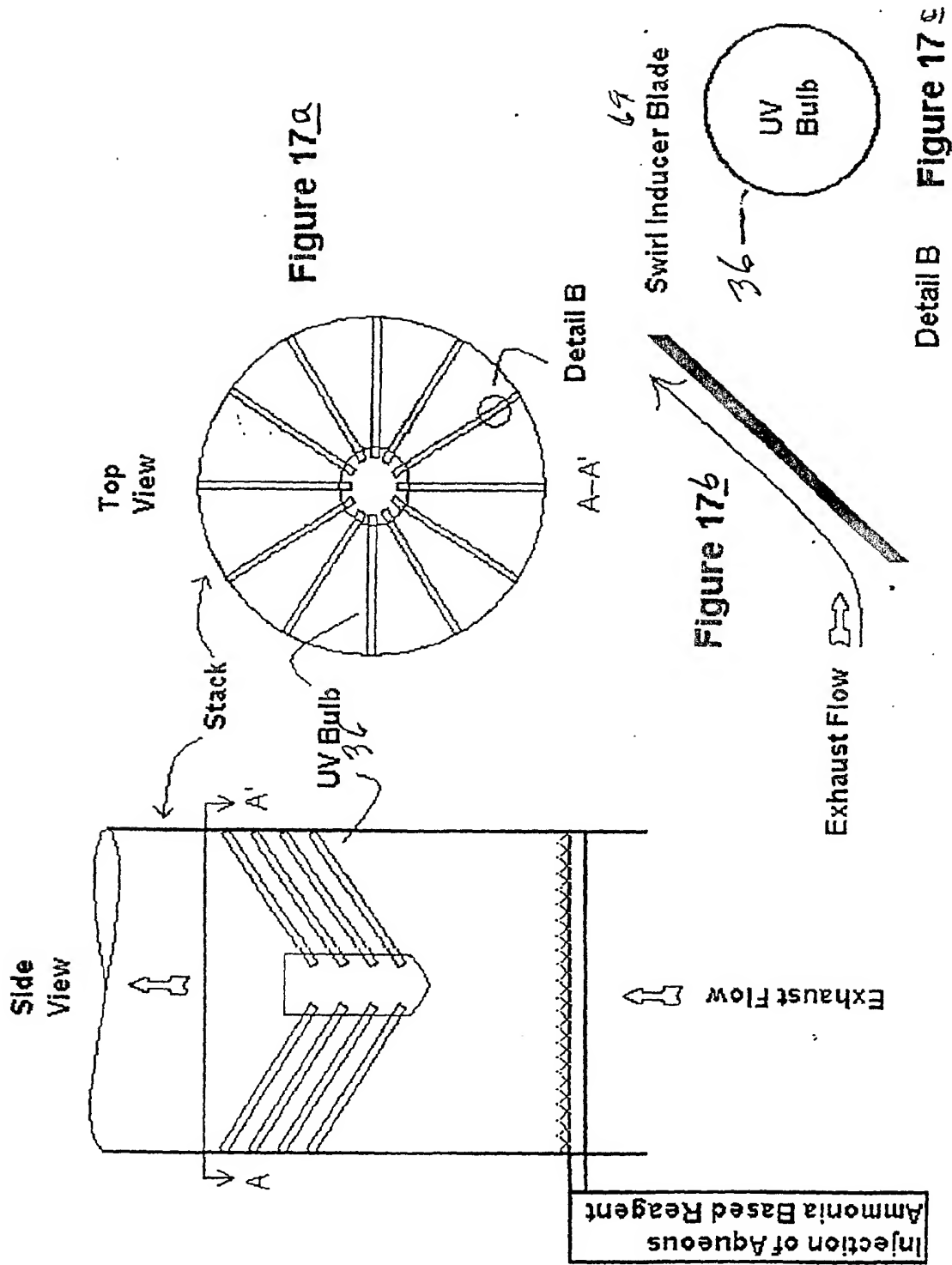


Figure 15 - Demonstration of ammonia gas mixing with lance or wall nozzle injection



**Figure 16 - Demonstration of ammonia gas mixing with a Venturi Plate**



**Figure 17 - Installation of the SUVR process on a hot exhaust stack using the vaporization of water to cool the exhaust gases and the thermal decomposition of urea to supply the ammonia**

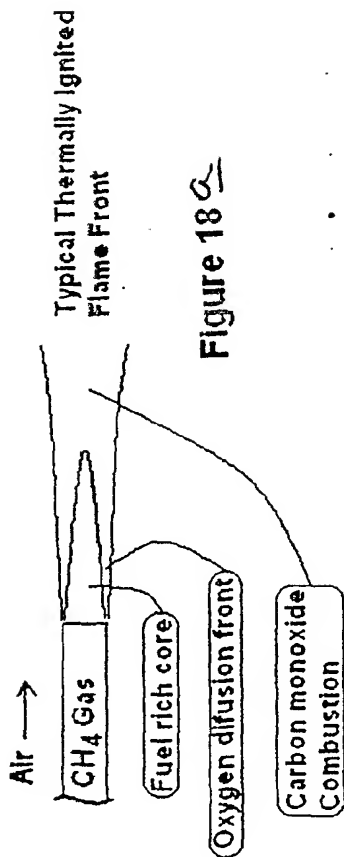


Figure 18 a

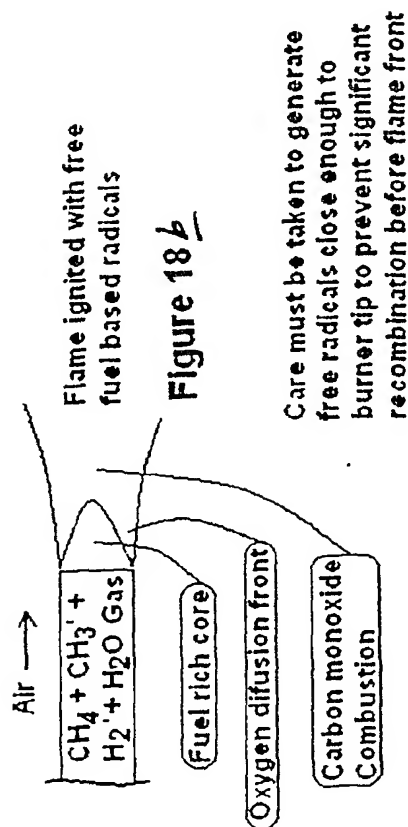


Figure 18 b

Care must be taken to generate free radicals close enough to burner tip to prevent significant recombination before flame front

Fuel based free radicals generated with the addition of 1-2% air or 1-4% water vapor added to fuel then exposed to ultraviolet light, dielectric barrier discharge, electron beam, or laser discharge.

Liquid Fuel requires longer residence time and higher water vapor content to promote gasification of liquid without coking. Reformer generated hydrogen gas can also be used to dilute liquid fraction.

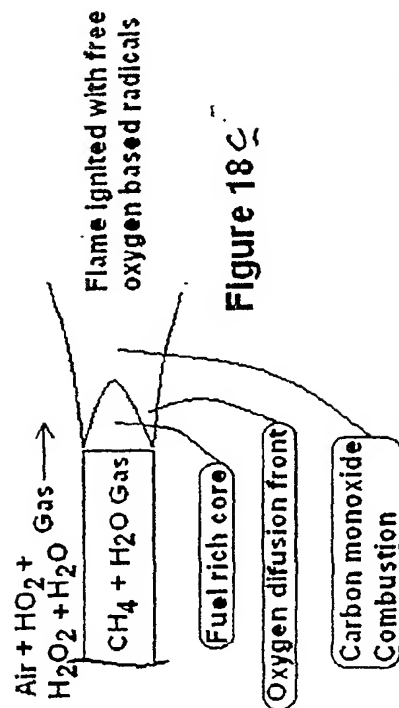


Figure 18 c

Oxygen based free radicals generated with the addition of 1-3% water vapor added to air then exposed to ultraviolet light, dielectric barrier discharge, electron beam, or laser discharge.

Figure 18 - Use of SUVR at burner to reduce VOC emissions. Increase Flame speed, and reduce NOx emissions

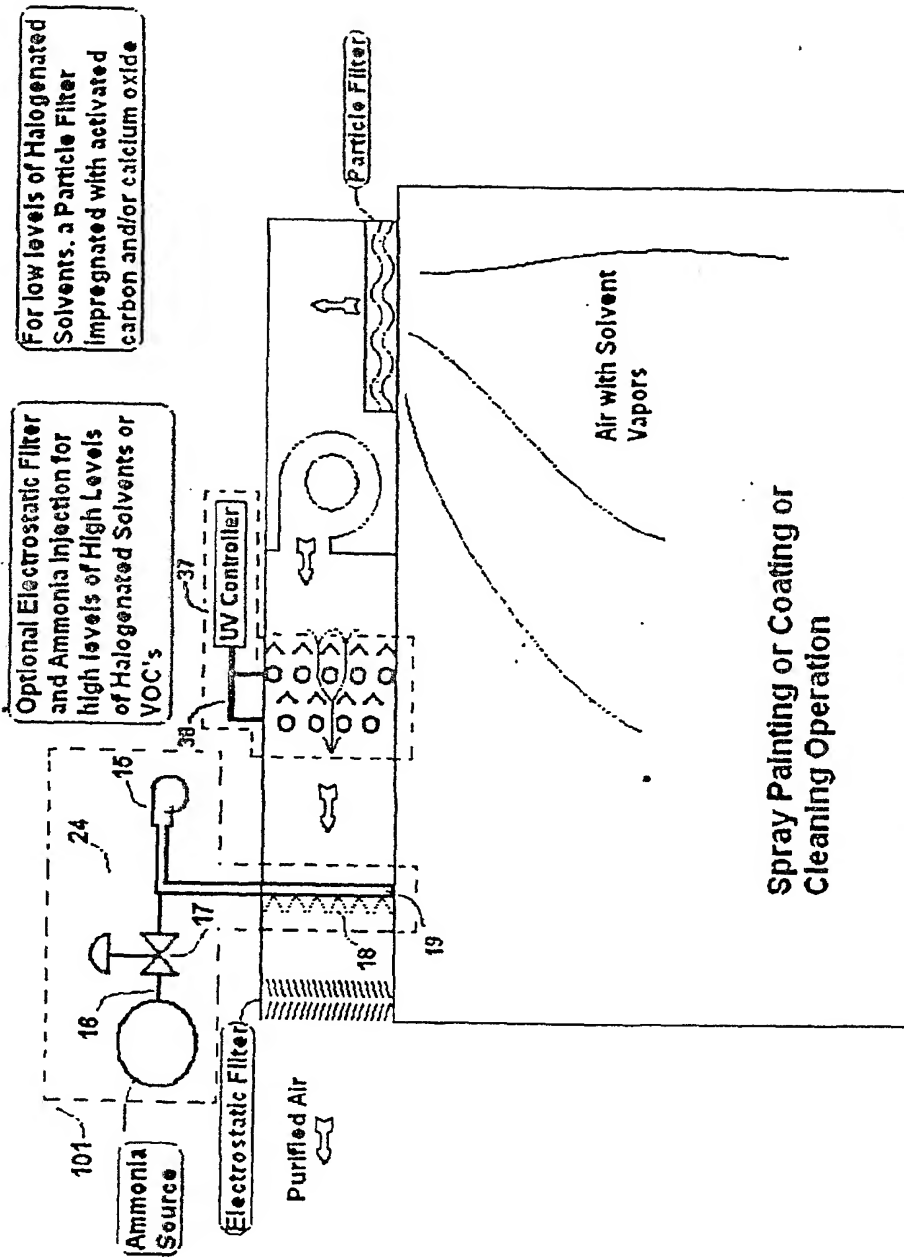
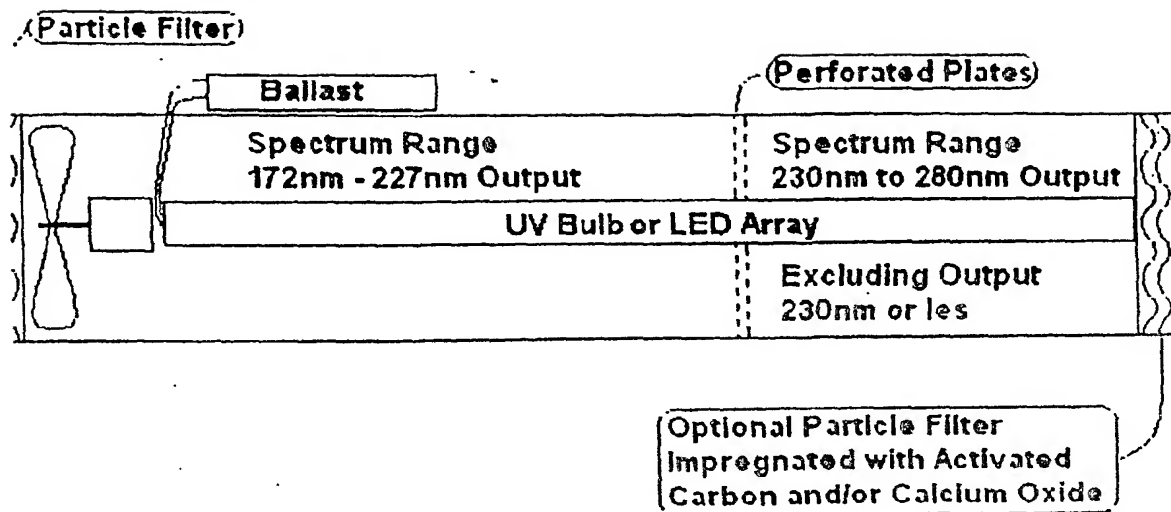


Figure 19 - Organic Compound Destruction Using SUVR with Optional Halogen Acid Removal



**Figure 20 - Portable SUVR unit for Organic Compound Destruction**